INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 5, 2026

IGI Report Number	LG851685450
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	HEXAGONAL MODIFIED STEP CUT
Measurements	12.41 X 7.88 X 4.22 MM

GRADING RESULTS

Carat Weight	3.00 CARATS
Color Grade	E
Clarity Grade	VVS 1

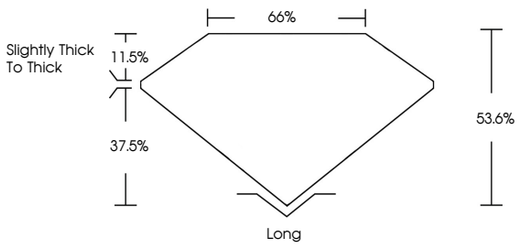
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG851685450

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG851685450
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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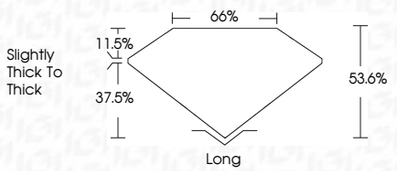
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IGI

November 5, 2026
IGI Report No LG851685450
HEXAGONAL MODIFIED STEP CUT
12.41 X 7.88 X 4.22 MM
Carat Weight 3.00 CARATS
Color Grade E
Clarity Grade VVS 1
Depth 53.6%
Table 66%
Girdle Slightly Thick To Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG851685450
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa